



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of :
Takashi Kisaichi :
Serial No.: [NEW] : Attn: Applications Branch
Filed: July 6, 2001 : Attorney Docket No.: OKI.250
For: SEMICONDUCTOR MANUFACTURING APPARATUS, AND POSITIONING JIG
USED FOR SAME

CLAIM OF PRIORITY

Honorable Assistant Commissioner for Patents and Trademarks,
Washington, D.C. 20231

Sir:

Applicants, in the above-identified application, hereby claim the priority date
under the International Convention of the following Japanese application:

Appln. No. 209929/2000 filed July 11, 2000

as acknowledged in the Declaration of the subject application.

A certified copy of said application is being submitted herewith.

Respectfully submitted,

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Dated: July 6, 2001

日 本 国 特 許 庁
JAPAN PATENT OFFICE

別紙添付の書類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed with this Office

出 願 年 月 日
Date of Application:

2000年 7月11日

出 願 番 号
Application Number:

特願2000-209929

出 願 人
Applicant(s):

沖電気工業株式会社

2001年 5月31日

特 許 庁 長 官
Commissioner,
Japan Patent Office

及 川 耕 造

